

In re the Application of:

Group Art Unit: 2825

Examiner: Whitmore, Stacy

Confirmation No.: 5787

For: METHOD AND SYSTEM FOR FACILITATING ELECTRONIC CIRCUIT AND CHIP DESIGN USING REMOTELY LOCATED RESOURCES

MAIL STOP AF

Dear Sir:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 11 of this paper.